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INFORMATION DISCLOSURE STATEMENT BY APPLICANT PTO-1449	Docket No. 52433/859	Application No. 10/588,837	
	Applicant(s) Hitoshi ASahi et al.	Examiner Vanessa T. Velasquez	
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U. S. PATENT DOCUMENTS

EXAMINER INITIAL	PATENT/PUBLICATION NUMBER	PATENT/PUBLICATION DATE mm/dd/yyyy	NAME	CLASS	SUBCLASS	FILING DATE*
/NTV/	4,067,756	01/10/1978	Koo et al.			
/NTV/	4,437,902	03/20/1984	Pickens et al.			
/NTV/	4,772,771	09/20/1988	Murayama et al.			

FOREIGN PATENT DOCUMENTS

EXAMINER INITIAL	DOCUMENT NUMBER	DATE mm/dd/yyyy	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
						Yes	No
/NTV/	1 382 703 A2	01/21/2004	Europe			Abstract	
	2001-355035	12/25/2001	Japan			Abstract	
	2003-96545	04/03/2003	Japan			Abstract	
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/NTV/	58-217628	12/17/1983	Japan			Abstract	

OTHER DOCUMENTS

EXAMINER INITIAL	AUTHOR, TITLE, DATE, PERTINENT PAGES, ETC.
/NTV/	European Search Report dated August 21, 2009 issued in corresponding European Application No. 05 71 0460

EXAMINER	/Vanessa T Velasquez/	DATE CONSIDERED	02/12/2010
EXAMINER: Initial if citation considered, whether or not citation is in conformance with M.P.E.P. 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.			